

## **bench development dedicated to microbarometers run-in**

In accordance with our ongoing quality approach, a running-in step for infrasound sensors has been investigated and implemented. Once the metrology process is completed, objective is to keep monitoring on sensitivity of MB3a sensors during several days, using the in-situ electrical calibration capability. For this purpose, a bench has been designed and characterized. Different sensitivity assessment methods have been compared. Testing conditions, bench design, methodology, and results are laid out in this poster.

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